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SERIAL NUMBER 10/807,931	FILING DATE 03/23/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SLA0586
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APPLICANTS

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** CONTINUING DATA *****

None WLL

** FOREIGN APPLICATIONS *****

None WLL

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/04/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY WA	SHEETS DRAWING 3	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 3
Verified and Acknowledged	Examiner's Signature <u>WLL</u> Initials				

ADDRESS

27518
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TITLE

Method to form local "silicon-on-nothing" or "silicon-on-insulator" wafers with tensile-strained silicon

FILING FEE RECEIVED 788	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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